

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Anisul Khan et al.

SERIAL NO.: 09/740,146

FILED: December 18, 2000

FOR: APPARATUS FOR PERFORMING
SELF CLEANING METHOD OF FORMING
DEEP TRENCHES IN SILICON SUBSTRATES

§ GROUP ART UNIT: 1763

§ EXAMINER: G. A. Goudreau

§ Attorney Docket No.:

§ AM-3396.D1

Date: February 3, 2004

AMENDMENT "B" UNDER 37 CFR § 1.111

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This Amendment "B" is in response to the Office Action mailed October 3, 2003, having a shortened statutory period for response of January 3, 2004. A request for a One Month Extension of Time to respond accompanies this Amendment "B", to extend the time for response through February 3, 2004.

Claims 37 - 55 are pending in the application. Claims 37 - 55 are rejected under 35 USC § 103(a) as being unpatentable over U.S. Patent No. 6,136,211, to Qian et al.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER074143341US in an envelope addressed to: Mail Stop Amendment (With Fee), Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: February 3, 2004

Shirley L. Church
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